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Joni Basch
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#35
K. Simon
10/24/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:
Henry J. Simon et al

Serial No.: 09/943,696

Filed: August 31, 2001

For: METHOD OF MEASURING
SURFACE PLASMON RESONANCE
USING INTERFERENCE
STRUCTURE OF REFLECTED
BEAM PROFILE

Group Art Unit:

Attorney Docket 1-21526

2877

INFORMATION DISCLOSURE STATEMENT
IN ACCORDANCE WITH 37 CFR §1.97

Honorable Sir:

Pursuant to 37 C.F.R. 1.97(b), record is hereby made of information that the Patent Office may wish to consider in connection with its examination of the above-identified application. Enclosed is a list of such information along with a legible copy of each document.

Respectfully submitted,

Shital A. Shah

Shital A. Shah
Registration No. 47,073

MacMillan, Sobanski & Todd, LLC
One Maritime Plaza, Fourth Floor
720 Water Street
Toledo, Ohio 43604
(419) 255-5900

TECHNOLOGY CENTER 2800

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